

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Reissue Application of:)	Evenines: Luz I. Aleiendre	#16
U.S. Patent No.: 5,803,975, issued 09/08/98)	: Examiner: Luz L. Alejandro) : Group Art Unit:1763)	1/2/02
Application No.: 09/657,971)		M/ h/
Filed:	September 8, 2000)		14100
	MICROWAVE PLASMA PROCESSING APPARATUS AND METHOD THEREFOR) :)	June 21, 2002 RFO	JUL-
	ioner for Patents con, D.C. 20231		JUL 1 - 2002	O S NED
PETITION UNDER 37 C.F.R. § 1.136(a)				

Sir:

Applicant petitions the Commissioner for Patents to extend the time for response to the Office Action dated December 21, 2001 for an additional two months from April 21, 2002 to June 21, 2002.

Submitted herewith is a check for \$810.00 to cover the fee for the extension under 37 C.F.R. § 1.17. Any deficiency in or overpayment of this fee should be

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I hereby certify that this correspondence is being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, Washington, D.C. 20231 on

June 21, 2002 (Date of Deposit)

Lawrence S. Perry, Reg. No.:

ttorney for Applicant)

June 21, 2002 Date of Signature charged or oredited to be posit Account No. 06-1205. A duplicate copy of this petition is enclosed.

Applicant's undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our

Respectfully submitted,

Attorney for Applicant

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